INTERNATIONAL SEARCH REPORT

anal Application No

Pul/ iB2004/003696 A. CLASSIFICATION OF SUBJECT MATTER IPC 7 B82B3/00 C23C16/04 H01J37/317 According to International Patent Classification (IPC) or to both national classification and IPC B. FIELDS SEARCHED Minimum documentation searched (classification system followed by classification symbols) C23C HO1JB82B Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched Electronic data base consulted during the international search (name of data base and, where practical, search terms used) EPO-Internal, WPI Data, PAJ, COMPENDEX C. DOCUMENTS CONSIDERED TO BE RELEVANT Relevant to claim No. Citation of document, with indication, where appropriate, of the relevant passages Category 9 1-4,7-10YAU S T ET AL: "LASER-ASSISTED DEPOSITION X OF NANOMETER STRUCTURES USING A SCANNING TUNNELING MICROSCOPE" APPLIED PHYSICS LETTERS, AMERICAN INSTITUTE OF PHYSICS, NEW YORK, US, vol. 57, no. 27, 31 December 1990 (1990-12-31), pages 2913-2915, XP000222958 ISSN: 0003-6951 5,6,11 the whole document γ US 5 294 465 A (GALLAGHER ET AL) 5.6 15 March 1994 (1994-03-15) column 6, lines 9-39; figure 1 column 13, lines 22-32; figure 6 -/--Patent family members are listed in annex. Further documents are listed in the continuation of box C. X Special categories of cited documents: *T* later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the "A" document defining the general state of the art which is not considered to be of particular relevance invention "E" earlier document but published on or after the international "X" document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to filing date *L* document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified) involve an inventive step when the document is taken alone "Y" document of particular relevance; the claimed invention connect or paracular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art. "O" document referring to an oral disclosure, use, exhibition or other means "P" document published prior to the international filing date but later than the priority date claimed *&* document member of the same patent family Date of mailing of the international search report Date of the actual completion of the international search 03/03/2005 27 January 2005 Authorized officer Name and mailing address of the ISA European Patent Office, P.B. 5818 Patentlaan 2 Pulpean Falent Onice, F.B. 3010 Falentia NL - 2280 HV Rijswijk Tel. (+31-70) 340-2040, Tx. 31 651 epo nl, Fax: (+31-70) 340-3016

Hoyer, W

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